

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jeong-Yeal KIM

Serial No.: 10/036,505

Group Art Unit: 2859

Filed: January 7, 2002

Examiner: Courson, Tania C

For: WAFER EDGE EXPOSURE APPARATUS, AND WAFER EDGE EXPOSURE  
METHOD

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST AND REVOCATION OF  
PRIOR POWERS

I, Jong-Yong YUN, President of Samsung Electronics Co., Ltd., having a place of business at 416 Maetan-Dong, Yeongtong-Gu Suwon-Si, Gyeonggi-do, Republic of Korea, assignee of the entire right, title and interest of the above-described U.S. patent application serial no. 10/036,505, by the assignment from Semiconductor Leading Edge Technologies, Inc, recorded in Reel/Frame 016325/0576 (3 pages), on June 10, 2005, represent that I am empowered to sign on behalf of assignee.

As assignee of the above identified application, all powers of attorney previously given are hereby revoked and the attorneys or patent agents associated with **Customer No. 20575** are hereby appointed to represent the undersigned before the United States Patent and Trademark Office (USPTO) in connection with any and all patent applications assigned only to the undersigned according to the USPTO assignment records or assignment documents attached to this form in accordance with 37 CFR (b).

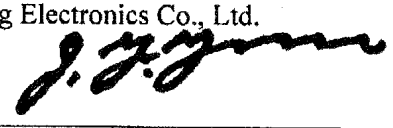
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Date:

May 3, 2006

  
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Jong-Yong YUN  
President